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35.C13630,

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MASAAKI IWANE ET AL.) Examiner: J. Diaz
Application No.: 09/346,678,) Group Art Unit: 2815
Filed: July 2, 1999)
For: CRYSTAL GROWTH PROCESS,)
SEMICONDUCTOR DEVICE,)
AND ITS PRODUCTION)
PROCESS : September 25, 2000

10/Electronic
J Steptoe
9/30/00

Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated September 8, 2000, Applicants elect to proceed initially with examination of Invention II, Claims 7-9.

Applicants respectfully request favorable consideration on the merits and early passage to issue of the elected claims.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100 or by

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facsimile at (212) 218-2200. All correspondence should
continue to be directed to our address given below.

Respectfully submitted,

L.P. Dianna
Attorney for Applicants

Registration No. 29,296 ✓

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801

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